

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



En re Application of:

Wu et al

Serial No.: 09/903,415

Filed: July 11, 2001

) Group No.: 1731

) Examiner: Unknown

) Docket No. LIGHT2140

For: METHOD OF FORMING AN OPTICAL COMPONENT

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CERTIFICATION UNDER 37 CFR § 1.8

I hereby certify that the documents referred to as enclosed herein are being deposited with the United States Postal Service as first class mail on this date 24 January 2002, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231

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Terrance A. Meador
Signature

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

INFORMATION DISCLOSURE STATEMENT

Applicant hereby cites the documents listed in accompany Form PTO-1449 with respect to the above-referenced patent application under the provisions of 37 CFR 1.97(b). Copies of the documents are attached.

The Examiner is respectfully requested to make the listed documents of record in connection with the prosecution of the subject application.

Respectfully submitted,

Date: 24 January 2002

Terrance A. Meador
TERRANCE A. MEADOR
Attorney for Applicant(s)
Registration No. 30,298

GRAY CARY WARE & FREIDENRICH
4365 Executive Drive, Suite 1100
San Diego, CA 92121-2133

Phone: 858/638-6747

Fax: 858/638-6727

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets needed as possible)				COMPLETE IF KNOWN	
				Application Number	09/903,415
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				First Named Inventor	Wu
				Group Art Unit	1731
				Examiner Name	Unknown
				Docket Number	LIGHT2140
SHEET	1	OF	6		

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		Number	Kind Code ² (If known)			
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		Office ³	Number ⁴	Kind Code ⁵ (If known)				
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
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				Examiner Name	Unknown
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SHEET	6	OF	6		

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